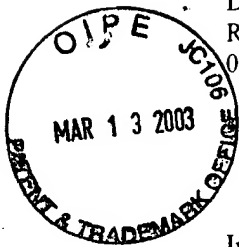


Docket No. 10001.000600 (NVLS 379)

Response To Office Action

03/10/2003



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

#17/B
3/20/03
Surler

In re Application of:

Craig L. Stevens et al.

Serial No. 09/872,796

Examiner: Erik J. Kielin

Filing Date: 06/01/2001

Art Unit: 2813

Title: Architecture For High Throughput Semiconductor Processing Applications

Honorable Commissioner of Patents
Washington, D.C. 20231

RESPONSE TO OFFICE ACTION

INTRODUCTORY COMMENTS

Sir:

This paper is responsive to the office action mailed on 12/12/2002 (hereinafter the "last office action").

Please amend the above-identified application as follows:

RECEIVED
MAR 18 2003
TECHNOLOGY CENTER 2800